

PROCEEDINGS OF SPIE

High-Power Lasers and Applications X

Ruxin Li
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Editors

22–23 October 2019
Hangzhou, China

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Published by
SPIE

Volume 11181

Proceedings of SPIE 0277-786X, V. 11181

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

High-Power Lasers and Applications X, edited by Ruxin Li, Upendra N. Singh, Shibin Jiang,
Proc. of SPIE Vol. 11181, 1118115 • © 2019 SPIE • CCC code: 0277-786X/19/\$21
doi: 10.1117/12.2560295

Proc. of SPIE Vol. 11181 1118115-1

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *High-Power Lasers and Applications X*, edited by Ruxin Li, Upendra N. Singh, Shibin Jiang, Proceedings of SPIE Vol. 11181 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X
ISSN: 1996-756X (electronic)

ISBN: 9781510630796
ISBN: 9781510630802 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
SPIE.org

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Contents

- v *Authors*
- vii *Symposium Committees*
- xi *Conference Committee*

LASER MATERIALS AND PROPERTIES

- 11181 01 **Pump-induced scattering in high-power Ti: Sapphire lasers [11181-7]**

HIGH PEAK POWER LASERS

- 11181 06 **Research on the cross polarization wave generation based on gadolinium gallium garnet crystal [11181-4]**

LASER MATERIALS AND PROPERTIES

- 11181 0A **Applicability of the discrete-dipole approximation to high-power laser scattering simulations of haze particles [11181-9]**

FIBER LASERS

- 11181 0C **2.9- μm passively Q-switched fiber laser using Au-nanocages as saturable absorber [11181-11]**
- 11181 0D **Power scaling analysis of single mode fiber amplifiers employing novel cladding-annular-doped ultra-low NA fiber [11181-12]**
- 11181 0F **2kW, 22GHz narrow linewidth polarization maintaining fiber amplifier with near-diffraction-limited beam quality [11181-14]**

FIBER NONLINEARITY AND SOURCES

- 11181 0K **Pulsed generation of multimode diode-pumped graded-index fiber Raman laser [11181-19]**
- 11181 0L **Investigation of shortwave edge in high-power supercontinuum with different peak power [11181-20]**

POSTER SESSION

- 11181 OM **All-optical arbitrary temporal shaping technology of broadband low-coherence light based on saturable absorption effect** [11181-21]
- 11181 OP **Numerical modeling of passively-Q quasi-three level Ho³⁺-doped fluorotellurite fiber lasers** [11181-24]
- 11181 OR **Optimization of the pulse detection structure of the active ranging optical system** [11181-26]
- 11181 OU **Effective mitigation of mode instability by deuterium loading in Yb-doped fiber oscillator** [11181-29]
- 11181 OV **Analysis of beam direction detection errors in solid-state slab laser beam clean-up systems** [11181-30]
- 11181 OW **Suppression effect of the spectral dispersion of sinusoidal phase modulated light on formation of hot images** [11181-31]
- 11181 10 **Development of fiber-based yellow laser for dermatological applications** [11181-35]
- 11181 11 **Selection of LP01 and LP11 modes in multimode graded-index fiber Raman laser by special FBGs** [11181-36]

Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Babin, Sergey A., 0K, 11
Bai, Jinqiang, 0A
Cao, Rui-ting, 0U
Chang, Zhe, 0F
Chen, Gui, 0U
Chen, Liezun, 0W
Chen, Shanqiu, 0V
Chen, Tao, 0P
Chen, Yi-sha, 0U
Cheng, X., 10
Chi, Hao, 0C
Chu, Hong, 01
Cui, S. Z., 10
Cui, Ziruo, 06
Dai, Neng-li, 0U
Dai, Zhiping, 0W
Dong, J. Y., 10
Dong, Kegong, 0L
Dong, Lizhi, 0V
Dostovalov, Alexander V., 11
Feng, Xi, 0D
Feng, Y., 10
Hong, Jinsuk, 0R
Huang, Hua, 0C
Huang, Shan, 0D
Jing, Feng, 0D
Jiang, Shurong, 0C
Kablukov, Sergey I., 0K, 11
Ke, Weiwei, 0F
Kim, Sug-Whan, 0R
Koh, Hae Seog, 0R
Kuznetsov, Alexey G., 0K, 11
Lai, Boheng, 0V
Li, Hai-qing, 0U
Li, Haokun, 0D
Li, Jiaxu, 0A
Li, Jin-yan, 0U
Li, Min, 0D
Li, Qingru, 0C
Li, Rao, 0M
Li, Xing-yu, 0P
Li, Yue, 0L
Liang, Xiao, 06
Lin, Honghuan, 0L
Ling, Xiaohui, 0W
Liu, Yong, 0C
Liu, Yu, 0D
Lu, Shizhuan, 0W
Ma, Shiqing, 0V
Ma, Shouhu, 0V
Ma, Yi, 0F
Nemov, Ilya N., 0K
Pan, Feng, 0A
Peng, Jing-gang, 0U
Peng, Wanjiang, 0F
Shen, Benjian, 0D
Shin, Jung-Hwan, 0R
Song, Peng, 0P
Su, Chunxuan, 0V
Sui, Daipeng, 0M
Sun, Meizhi, 06
Sun, Mingying, 0M
Sun, Yinhong, 0F
Tang, Chun, 0F
Tao, Rumao, 0D
Tarasov, Aleksandr A., 01
Wang, Jianjun, 0D, 0L
Wang, Xiaochao, 0M
Wang, Xun, 0V
Wang, Yanshan, 0F
Wang, Yi-bo, 0U
Wang, Youwen, 0W
Wei, Chen, 0C
Wolf, Alexey A., 0K, 11
Wu, Zhensen, 0A
Xia, Wei, 0P
Xie, Lianghua, 0D
Xie, Xinglong, 06
Xing, Ying-bin, 0U
Xu, Bing, 0V
Xu, Hao-zhen, 0U
Xu, Qiang, 0A
Yan, Donglin, 0L
Yang, Kangjian, 0V
Yang, Lu-yun, 0U
Yang, Qingwei, 06
Yang, Shunhua, 06
Zeng, X., 10
Zhang, Han, 0C
Zhang, Haoyu, 0L
Zhang, Ya-ping, 0P
Zhao, Wang, 0V
Zhong, Yiqing, 0W
Zhou, Cheng, 0P
Zhou, Liqiang, 0C
Zhu, Jianqiang, 06
Zhu, Ping, 06
Zhu, Rihong, 0F

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